

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re U.S. Patent Application

OSHIMA *et al.*

Application Number 09/987,914

Filed November 16, 2001

For: SEMICONDUCTOR DEVICE  
AND ITS FABRICATION METHOD

Attorney Docket No. HITA.0120



Art Unit 2826

Examiner  
Williams, Alexander O.

RECEIVED  
SEP 13 2002  
TECHNOLOGY CENTER 2800

#5/Election  
Assumed  
9/17/02

Honorable Assistant Commissioner  
for Patents  
Washington, D.C. 20231

**RESPONSE AND AMENDMENT UNDER 37 C.F.R. § 1.111**

Sir:

This is in response to the Office Action dated August 23, 2002, the period for response to which will expire on September 23, 2002. Applicants hereby elect the continuing prosecution of Group II, claims 18-37, drawn to a method of fabricating a semiconductor device, without traverse.

**REMARKS**

The above election along with the following remarks are being submitted as a full and complete response to the Official Action dated August 23, 2002, the period for response to which will expire on September 23, 2002. The Examiner is respectfully requested to review the substance of Group II: claims 18-37, and to indicate the allowability of the claims.

Claims 18-37 drawn to a method of fabricating a semiconductor device have been elected in this application, while other claims are withdrawn from further prosecution without prejudice. Applicants hereby reserve the right to file a divisional application on any or all of the non-elected claims.